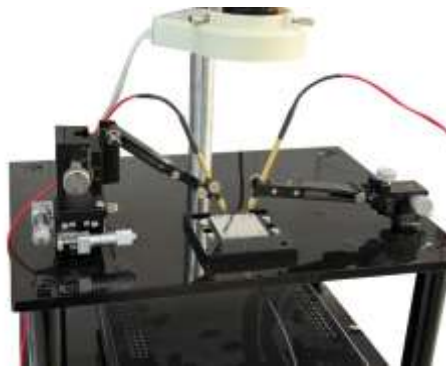
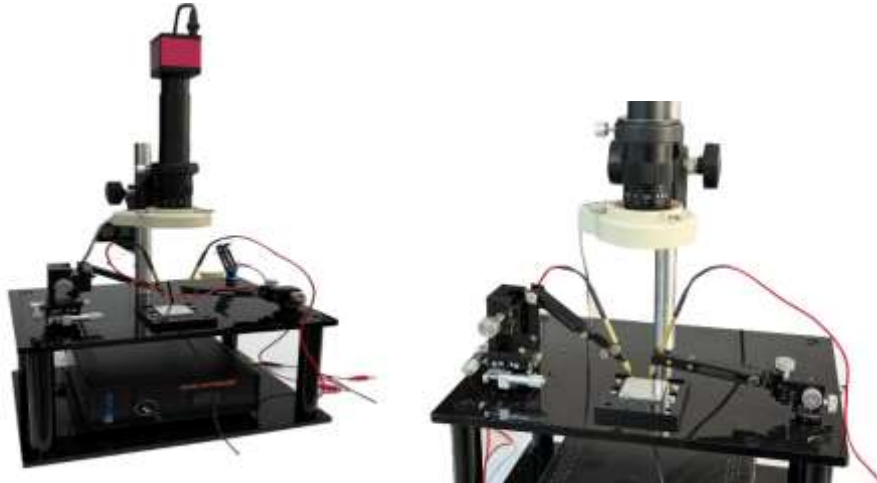




# THIN FILM TRANSISTOR CHARACTERIZATION SYSTEM



The system is a complete THIN FILM TRANSISTOR CHARACTERIZATION system.

## Technical Datasheet

The system contains the following elements:

Sourcemeeter

Probe station

Voltage range: -200 V to +200 V

Current range: 10Pa-1A

Software

**PROBE STATION** can be used for current-voltage characteristics of electronic devices such as solar cell, photodiode, sensor and thin film transistors. Probe station is designed according to below technical properties

XYZ manipulators ( 2 or 3 )

Vacuum chuck

Temperature chuck

Temperature controller

Microscope for thin film transistor applications

High resolution camera: 5 MPA

Magnification: 130X

Monitor

Probe pin: Spring pin